

Attorney Docket: BHT/3230-63

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicant** 

TSUI

Application No.

10/625,516

Filed

July 24, 2003

Title

STRUCTURE OF METAL OXIDE SEMICONDUCTOR

FIELD EFFECT TRANSISTOR

Group Art Unit

2813

Examiner

C. Thompson

Docket No.

BHT/3230-63

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **INFORMATION DISCLOSURE STATEMENT**

Sir:

In compliance with the duty of disclosure under 37 CFR 1.56, and 37 CFR 1.97-1.98, the documents listed on the attached form PTO-1449 are hereby made of record in this patent application. Copies of the listed documents are enclosed.

As this Information Disclosure Statement is being filed following the issuance of the first Official Action in this application, the appropriate fee is also enclosed, in order to have the enclosed references considered by the Examiner and made of record in the application.

08/03/2004 HLE333

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Respectfully submitted,

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180.00 QP

Date: August 2, 2004

By:

Bruce H. Troxell Reg. No. 26,592

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FORM PTO 1449 (modified)  U.S. DEPARTMENADE COMMERCE			APPLICANT TSUI								
PATENT AND TRADEMARK OFFICE  LIST OF REFERENCES CITED BY APPLICANT(S)			FILING DATE July 24, 2003 GROUP 2			3					
Date Submitted to PTO: Aug	several sheets if necessary) gust 2, 2004	U.S. P	ATENT DOCUMENTS								
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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT					
	OTHER	DOCUMENT(S) (Inclu	ding Author, Title, Date, Pertinent Pa	ages, Etc.)							
	C.J. Koenek	C.J. Koeneke, et al.; "Schottky MOSFET for VLSI"; in Dig. of IEDM, p. 367; 1981									
		S.E. Swirhun et al.; "A VLSI Suitable Schottky Barrier CMOS Process"; IEEE, Trans. Electron Devices; Vol. ED-32, No. 2; p. 194; 1985									
		B.Y. Tsui et al.; "A Novel Process For High-Performance Schottky Barrier PMOS"; J. Electrochem. Soc.; Vol. 136, No. 5; p. 1456; 1989									
		C. Wang et al.; "Sub-50-nm PtSi Schottky Source/Drain p-MOSFETs"; in Proc. of Device Research Conf.; p/72; 1998									
		C. Wang et al.; "Sub-50-nm PtSi Schotty Source/Drain Metal-Oxide-Semiconductor Field-Effect Transistors; Appl. Phys. Lett.; Vol. 74, No. 8; p. 1174; 1999									
		W. Saitoh et al.; "35 nm Metal Gate SOI-p-MOSFETs With PtSi Schottky Source/Drain"; in Proc. of Device Research Conf.; p. 30; 1999									
		A. Itoh et al.; "Very Short Channel Metal-Gate Schottky Source/Drain SOI-PMOSFETs And Their Short Channel Effect"; in Proc. of Device Research Conf.; p. 77; 2000									
	Processing,	H.C. Lin et al.; "A Novel Implantless MOS Thin-Film Transistor With Simple Processing, Excellent Performance, and Ambipolar Operation Capability"; in Dig. of IEDM; p. 857; 2000									
	Metal-Oxide-	K. Uchida et al.; "Enhancement Of Hot-Electron Generation Rate in Schottky Source Metal-Oxide-Semiconductor Field-Effect Transistors"; Appl. Phys. Lett.; Vol. 76, No. 26; p. 3992; 2000									
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<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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